OTPE 480

PTO/SB/08A (02-03) Approved for use through 04/30/2003, OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Paperwork Bateuction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Complete if Known

Substitute for form 1449/PTO

Sheet

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known				
Application Number	10/716,006			
Filing Date	11/18/2003			
First Named Inventor	Mehregany			
Art Unit	1775			
Examiner Name	Archene A. Turner			
Attorney Docket Number	29438/04001			

	1	-		DOCUMENTS	
Examiner Initials*	Cite No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevan Figures Appear
		Number-Kind Code ² (# known)			1 igores Appear
Zh_		US- 5,616,426	04-01-1997	Tenbover et al.	
9		US- 6,189,766 B1	02-20-2001	Baker et al.	
1		US-			
		US-			
		US-			
		US-	1		
		US-			,
		US-	†		
-		US-			
		US-			
		US-			
		US-	1		
		US-			
		US-		,	
		US-			
		US∙	1		
		US-			
		US-			1
		US-	1		

		FORE	IGN PATENT DOCL	JMENTS	•	
Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages	
		Country Code ³ Number ⁴ Kind Code ⁵ (# known)	MM-00-1111		Or Relevant Figures Appear	'
<i>I</i> R		EP 0445 319 A1	09-11-1991	International Business Machines Corp.		
- (-						
						\sqcap
				T		

Examiner Signature	Date Considered	12/05	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional), ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁴ Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patenta, Washington, DC 20231.

PTO/SB/08B (02-03)
Approved for use through 04/30/2003. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE
B. R. collection of information unless it contribe a unit 04/3 contribe as a collection.

Substitute for form 1449/PTO				Complete if Known		
300301011	010/10/11/14/3/10			Application Number	10/716,006	
INFO	RMATION	DIS	CLOSURE	Filing Date	11/18/2003	
STATEMENT BY APPLICANT			PPLICANT	First Named Inventor	Mehregany	
	41			Art Unit	1775	
	(Use as many sheets as necessary)			Examiner Name	Archene A. Turner	
Sheet	2	of	2	Attorney Docket Number	29438/04001	

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
A		Hwang, J-D et al, "Epitaxial Growth and Electrical Characteristics of Beta-SiC on Si by Low-Pressure Rapid Thermal Chemical Vapor Deposition." Japanese Journal of Applied Physics. Tokyo, JP, vol. 34, no. 3, Part 1, March 1995 (1995-03), pgs. 1447-1450. XP-000703002	
		Sarro, P. M. et al.; "Low-Stress PECVD SiC thin films for IC-compatible microstructures." Sensors and Actuators A, Eisevier Sequoia S.A., Lausanne, CH, vol, 67, no. 1-3, May 15, 1998, pgs. 175-180.	
A		Search Report for PCT/US2004/037064, published 9/12/2005.	
-5.3			
			·
			
		•	

Examiner Signature		Date Considered	12/04
			7 - 7 - 7

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.